

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Tadashi MAEGAWA, et. al.

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For: SUBSTRATE PROCESSING APPARATUS

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Examiner: Sylvia MacARTHUR

VIA EFS WEB
Commissioner for Patents
P.O. Box 1450
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SUBMISSION

Sir:

Submitted herewith is a copy of art cited in a communication from a foreign patent office in a counterpart foreign application, together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in connection with a corresponding patent application, to the best of applicant's knowledge, not more than three months prior to the filing of this Submission. A translation of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the cited prior art.

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Respectfully submitted,

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MAX MOSKOWITZ
Registration No.: 30,576
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700